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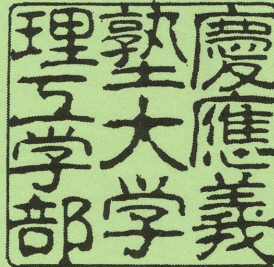
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EFFECT OF O^+ ION BEAM ON THE ELECTRICAL
CONDUCTION OF CARBON FILMS
BY IBSD TECHNIQUE

By

YOSHIKO OHASHI and TAKUYA ISE



FACULTY OF SCIENCE AND TECHNOLOGY
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